

7th WORKSHOP

Hybrid

# EUV-FEL

EUV-FEL Light Source Study Group for Industrialization, iCASA/ KEK

30 January, 2023

1:00PM-5:40PM (JST)

Including cERL and STF Sitetour



## Keynote lecturer:

Harry Levinson (HJL Lithography)

## Invited speakers:

Takeo Watanabe (University of Hyogo)

Norio Nakamura (KEK)

Takahiro Kozawa (Osaka University),

Seiji Nagahara (Tokyo Electron Co. LTD.)

## Session Chairs

Akiyoshi Suzuki

Shigemi Sasaki

Shinji Okazaki

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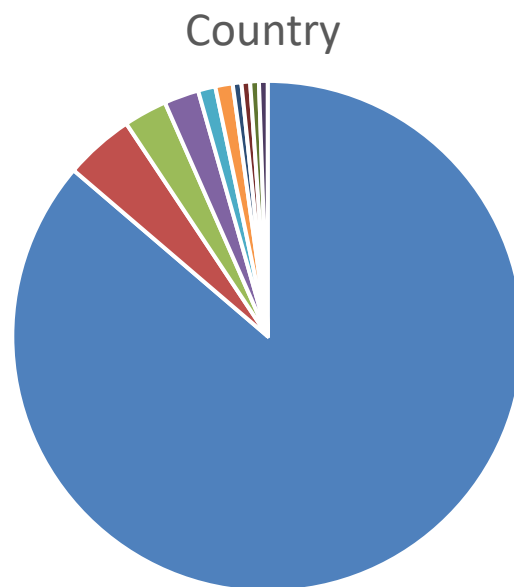
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## Participants

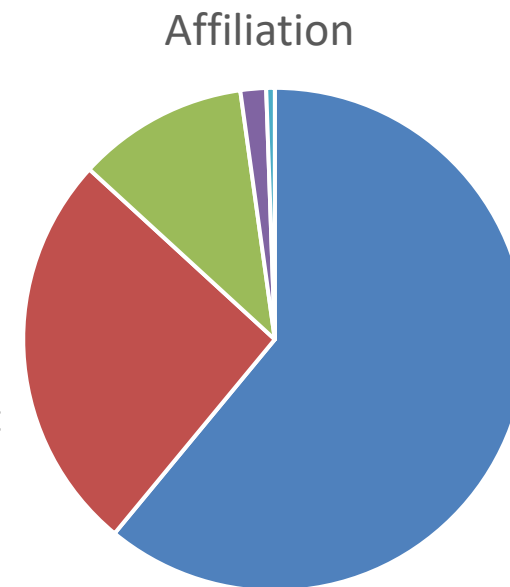
Number of registers; 186 @29/January/2023

Country	Number
Japan	161
United States	8
China	5
Taiwan	4
Belgium	2
Netherlands	2
Germany	1
Jersey	1
Korea	1
Romania	1
	<b>186</b>



Affiliation	Number
Company	111
Research institution	51
University	20
Consultant	3
Other	1
	0
	0
	<b>186</b>

- Company
- Research institution
- University
- Consultant
- Other



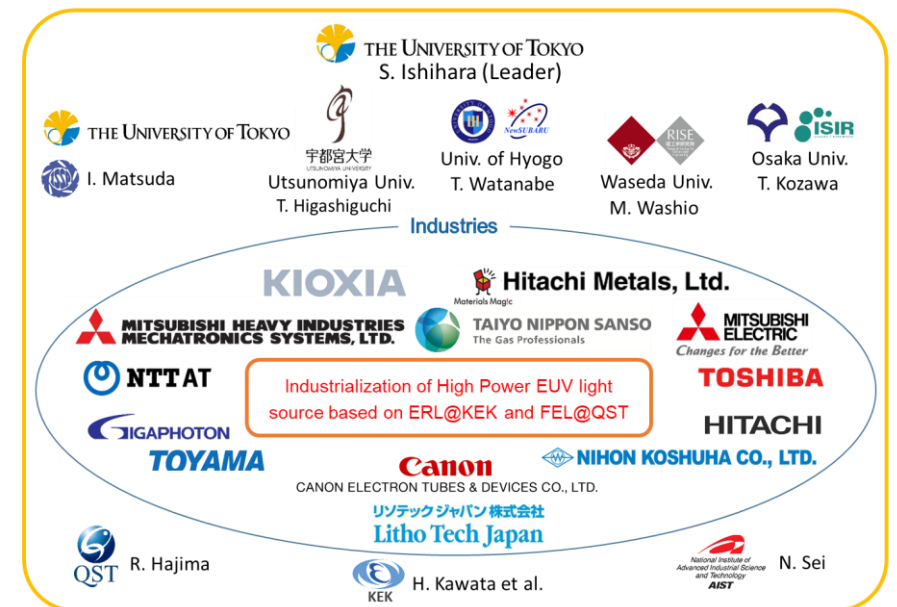


## Organizers

EUV-FEL Light Source Study Group for Industrialization  
 High energy accelerator Research Organization (KEK)  
 Innovation Center for Applied Superconducting Accelerator



EUV-FEL Light Source Study Group for Industrialization



## Special Thanks

Workshop secretary; Hitomi Kusama